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Mobile Cubic Asher Specifications Sheet

The MCA plasma process is unlike 'plasma cleaning' typically used by electron microscopists. Radical downstream plasma cleaning is a chemical process to ash hydrocarbons delicately with virtually zero K.E. This process provides high resolution imaging at low landing energy.



Mobile Cubic Asher Specifications

 $^{1}/_{8}$ " N₂ vent

Up to 99 Watts at 13.56 MHz

Down to 70 mTorr

Shutoff leakage - 1E-8 Torr I/s, 1.3E-9 Pa-m3/s

Opto-isolated COM port for Windows OS

Up to 3 TEM Holders

3-Position toggle (Pump-Off-Vent)

7" Touchscreen Control Panel

Qwk-Switch[™] Source mounting to transfer to SEM

100-230 VAC, 50/60 Hz, Power consumption 500VA at 50 Ohms

HxWxD 36 x 102 x 51 cm / 40" x 20" x 14"

Viewport Al chamber 7" x 7"

Weight 120lbs / 55 kg

GV10x Remote Control software v1.7

Set and monitor - cleaning Power & Duration

Close e-Gun Pop-up Warning

Pressure Trigger: Automates plasma ignition when Source's pirani reaches preset pressure

Stores up to 10 recipes simultaneously

Windows OS compatible

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|------|---|
| PN# | Mobile Cubic Asher |
| MCA | Mobile Cubic Asher: |
| | Chamber |
| | GV10x Qwk-Switch[™] DS Source |
| | Controller |
| | ibss Software |
| | 60 l/m Scroll Pump w/ Shutoff Valve & MicroPirani |
| | TEM Holder Sleeves |
| J-CS | JEOL TEM Holder Sleeve & Plug |
| F-CS | FEI TEM Holder Sleeve & Plug |
| H-CS | Hitachi TEM Holder Sleeve & Plug |
| | Optional SEM Cleaning Items |
| QSP | Qwk-Switch Spooler for SEM Chamber cleaning – One per SEM |
| MP | MicroPirani |
| | |

GCR 500 psi Gas Cylinder & Regulator 14.25" x 3.53" Plasma Driving gas

¹ Identify SEM[s] port dimension to select correct spooler

Gentle Asher[®] & GV10x Asher[®] are ibss Group, Inc. Trademarks

Prices:FOB Burlingame, CATerms:Net 30 DaysDelivery:4 weeks AROWarranty:Three Year Limited

